INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 1, 2026

IGI Report Number	LG843629010
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL MIXED CUT
Measurements	11.28 X 7.70 X 4.76 MM

GRADING RESULTS

Carat Weight	2.79 CARATS
Color Grade	D
Clarity Grade	VVS 1

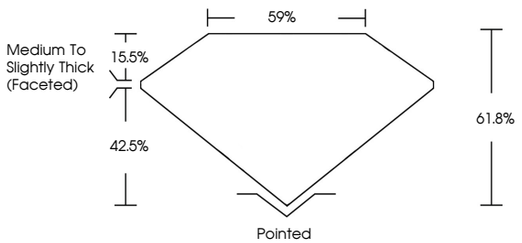
ADDITIONAL GRADING INFORMATION

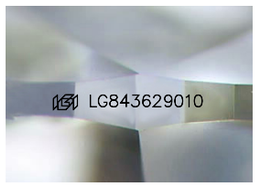
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG843629010

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG843629010
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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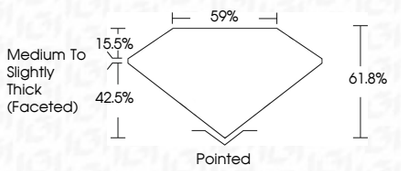
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IGI

October 1, 2026
IGI Report No LG843629010
OVAL MIXED CUT
11.28 X 7.70 X 4.76 MM
Carat Weight 2.79 CARATS
Color Grade D
Clarity Grade VVS 1
Depth 61.8%
Table 59%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG843629010
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa